

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT** ( Not for submission under 37 CFR 1.99)

Application Number	10803999
Filing Date	2004-03-19
First Named Inventor	TAKAHASHI, Miki et al.
Art Unit	1752
Examiner Name	LEE, Sin J.
Attorney Docket Number	Q80517

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SJL	1	6884565		2005-04-26	Takahashi et al.	

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SJL	1	0 894 622	EP	A2	1999-02-03	Fuji Photo Film Co., Ltd.		<input type="checkbox"/>
	2	0 965 887	EP	A1	1999-12-22	Fuji Photo Film Co., Ltd.		<input type="checkbox"/>
	3	1 513 016	EP	A2	2005-03-09	Fuji Photo Film Co., Ltd.		<input type="checkbox"/>

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STL	4	1 464 487	EP	A2	2004-10-06	Mitsubishi Chemical Corporation	<input type="checkbox"/>
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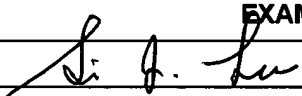
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